



2818
JFW

PATENT
8040-1041

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Masamoto TAGO et al.

Confirmation No. 9072

Serial No. 09/613,331

GROUP 2818

Filed July 7, 2000

Examiner Quoc Dinh Hoang

SYSTEM SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THE SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 25, 2004

Sir:

Responsive to the Official Action of July 23, 2004,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing
of claims that begins on page 2 of this paper.

Remarks begin on page 7 of this paper.